

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Yoshiyuki USHIGAMI et al.
 U.S. Application No. : 10/500,994
 International Application No. : PCT/JP03/00043
 International Filing Date : January 7, 2003
 For : METHOD FOR MANUFACTURING GRAIN-ORIENTED SILICON STEEL SHEETS WITH MIRROR-LIKE SURFACE

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450
 Mail Stop PCT

**TRANSMITTAL OF MISSING REQUIREMENTS
UNDER 35 U.S.C. 371**

S I R :

Applicants submit herewith a fully executed Declaration and Power of Attorney in order to complete the filing requirements under 35 U.S.C. 371 for the U.S. national phase of the above-identified PCT application. **A copy of the Notification of Missing Requirements has not been received in the above-referenced application.**

The U.S. Patent and Trademark Office is authorized to charge the \$130.00 fee to cover the surcharge for filing of the Declaration and Power of Attorney to Deposit Account No. 11-0600.

The Commissioner is also authorized to charge any additional fees, any extension fees or credit any overpayment to the deposit account of **Kenyon & Kenyon**, deposit account **no. 11-0600**. A duplicate copy of this paper is enclosed.

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Date: *JAN 12, 2005*

Respectfully submitted,

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